

Application/Control No.	Applicant(s)/Patent under Reexamination
10/789,799	KUO, FRANK
Examiner	Art Unit
EDMUND H. LEE	1791

	SEARCHED				
Class	Subclass	Date	Examiner		
UPDATED		5/24/2008	EHL		

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
264	272.17	5/24/2008	EHL		
	275,328.8				
	328.12				
264/3	328.9				

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
UPDATED	5/24/2008	EHL
264/272.17,275,328.8,328.12,328.9		